



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re the Application of

Kazuo USHIDA et al.

Group Art Unit: 2851

Application No.: 09/320,472

Examiner: A. Mathews

Filed: May 25, 1999

Docket No.: 110197.98

For: PROJECTION EXPOSURE APPARATUS

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Jr  
2/27/02

**RESPONSE TO QUAYLE ACTION  
AND SURRENDER OF LETTERS PATENT  
PRIOR TO ISSUANCE OF REISSUE APPLICATION**

Director of the U.S. Patent and Trademark Office  
Washington, D.C. 20231

Sir:

In response to the Quayle Action dated November 20, 2001, attached hereto for surrender is the original Letters Patent on which the above-identified Reissue Application is based. Applicants submit that all requirements set forth in the Quayle Action have been satisfied and that, therefore this application is in condition for allowance.

Should the Examiner believe anything further would be desirable to place this application in even better condition for allowance, the Examiner is invited to contact Applicants' undersigned attorney at the telephone number listed below.

Respectfully submitted,

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JAO:MAC/ccs

Attachment:

Original Letters Patent No. 5,530,518

Date: December 4, 2001

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**DEPOSIT ACCOUNT USE**

**AUTHORIZATION**

Please grant any extension  
necessary for entry;

Charge any fee due to our  
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